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PATENT**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicants: Eun -Kyung Lee Conf. No.: 5019

Application No.: 10/758,136 Examiner: Laura M. Schillinger

Filing Date: January 16, 2004 Art Unit: 2813

Title: METHOD OF MANUFACTURING SILICON
OPTOELECTRONIC DEVICE, SILICON
OPTOELECTRONIC DEVICE MANUFACTURED BY THE
METHOD AND IMAGE INPUT AND/OR OUTPUT
APPARATUS USING THE SILICON OPTOELECTRONIC
DEVICE

Attorney Docket: 2557SI-001230/US/CPA

Customer Service Window
Randolph Building
401 Dulany Street
Alexandria, VA 22314
Mail Stop Amendment

January 20, 2010

AMENDMENT UNDER 37 C.F.R. § 1.111

Sir/Madam:

In response to the Office Action mailed September 20, 2005, the following amendments and remarks are respectfully submitted in connection with the above-identified application.

Amendments to the Specification begin on page 2 of this paper.

Listing of the Claims begin on page 3 of this paper.

Remarks begin on page 10 of this paper.

	Claims remaining after Amendment		Highest number previously paid for		Present extra
Total	35	-	35	=	0
Independent	2	-	3	=	0